**SECONDARY BATTERY** 

Positive pole for lithium sec. cell for power source of small and light wt. electronic appts. - comprising material contg. at least lithium is vapour deposited on electrode substrate, and oxide film contg. lithium-oxide formed

on substrate [Derwent Record]

♥Country:

JP Japan Α

€Kind:

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9 Application

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H01M 4/04; C23C 14/22;

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PURPOSE: To provide a manufacturing method of a positive electrode for a lithium secondary battery by which performance of an electrode base body can be improved by improving adhesion of a film being formed with the electrode base body, improving crystallinity of the film, and reducing a defect in the film.

CONSTITUTION: While blowing oxygen gas against a base body S from an oxygen gas supply part 7, or while causing high

frequency discharge in a vessel 1, or while irradiating an

electromagnetic wave to the base body S from an ultraviolet lamp 9. or while performing operation by combining these with each other, evaporation of a substance 3a containing at least lithium and ion irradiation are performed.

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ਊ Family:

None

**<sup>™</sup>Other Abstract** 

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Patent Details:

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JP 8287901 A 6 H01M-004/04

Abstract (Basic): JP 8287901 A

Method comprises: (a) a material contg. at least Li is vapour deposited on an electrode substrate and simultaneously ions are irradiated on the substrate; and (b) an oxide film contg. at least Li-oxide is formed on the substrate by blowing O2 on the substrate.

USE - The cell is suitable for power source of smaller size and

light wt. electronic appts..

ADVANTAGE - The electrode has improved property since adhesiveness of the oxide film with the electrode substrate is improved.

Dwg.1/1

Title Terms: POSITIVE: POLE: LITHIUM; SEC; CELL; POWER; SOURCE; LIGHT;

WEIGHT; ELECTRONIC; APPARATUS; COMPRISE; MATERIAL; CONTAIN; LITHIUM;

VAPOUR; DEPOSIT; ELECTRODE; SUBSTRATE; OXIDE; FILM; CONTAIN; LITHIUM;

OXIDE; FORMING; SUBSTRATE

Derwent Class: L03; X16

International Patent Class (Main): H01M-004/04 International Patent Class (Additional): C23C-014/22

File Segment: CPI; EPI

Manual Codes (CPI/A-N): L03-E01B5 Manual Codes (EPI/S-X): X16-E08A